

FIG. 1

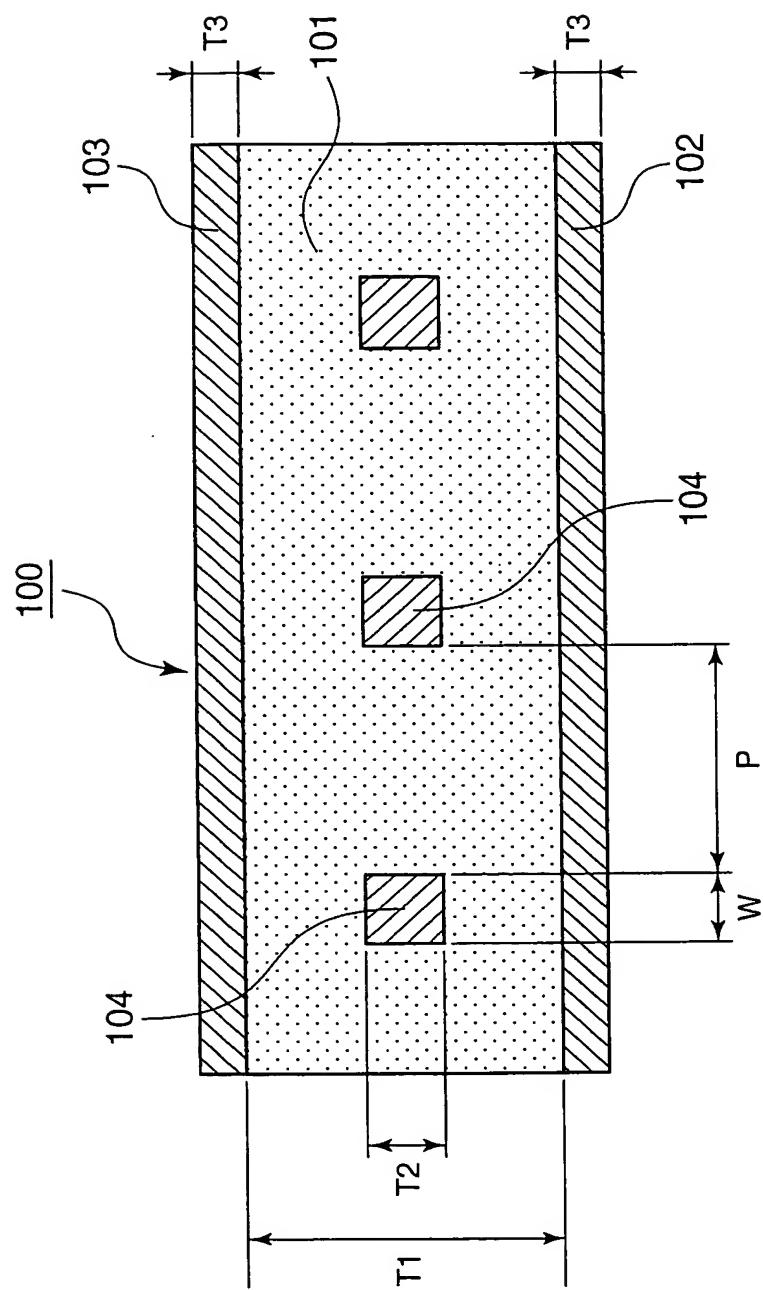
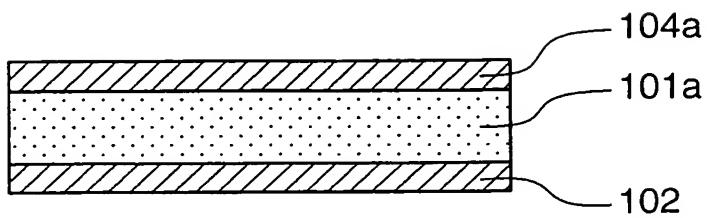
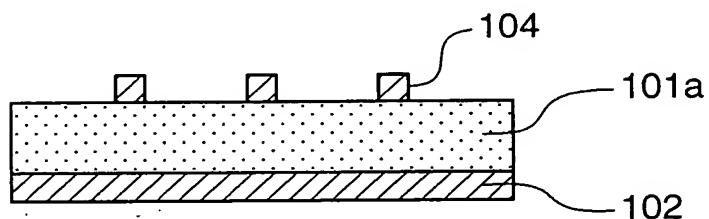
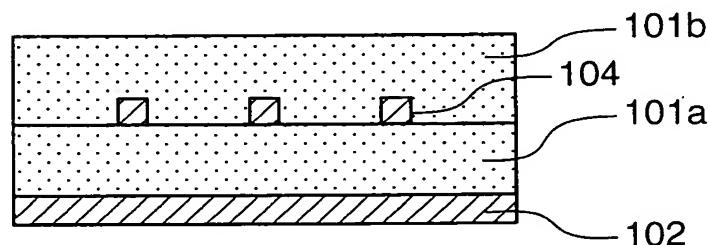
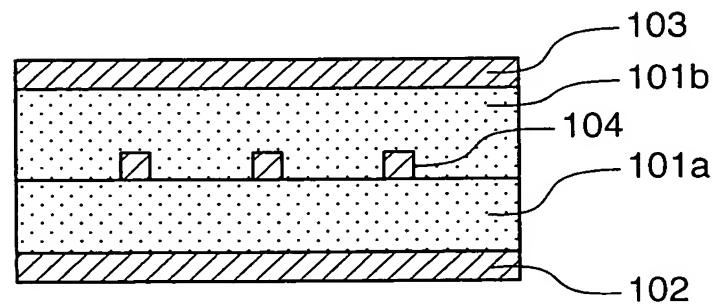


FIG. 2

**FIG. 3A****FIG. 3B****FIG. 3C****FIG. 3D**

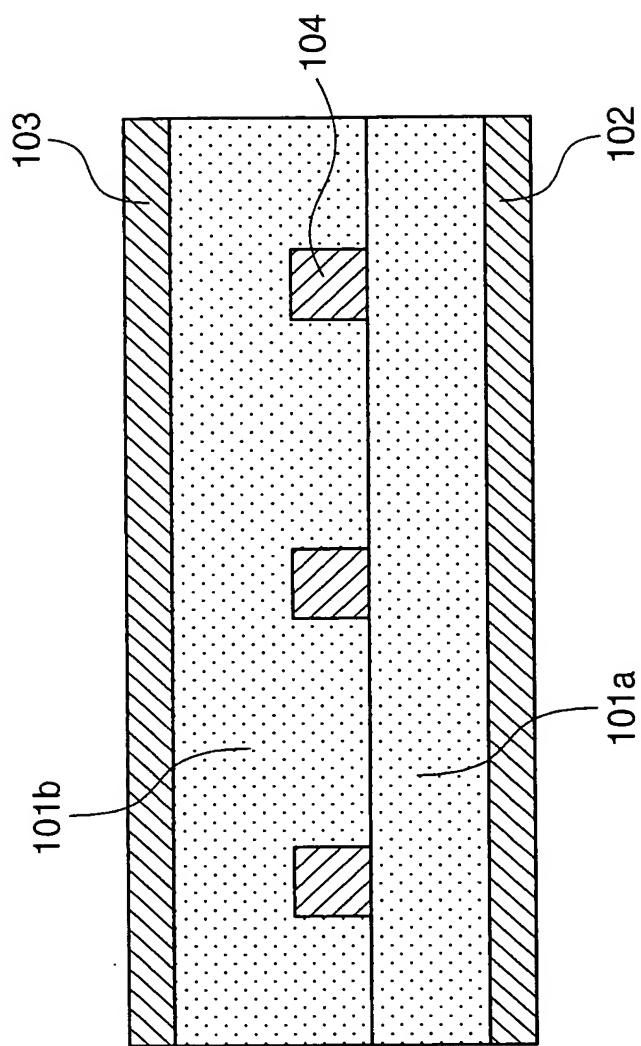


FIG. 4

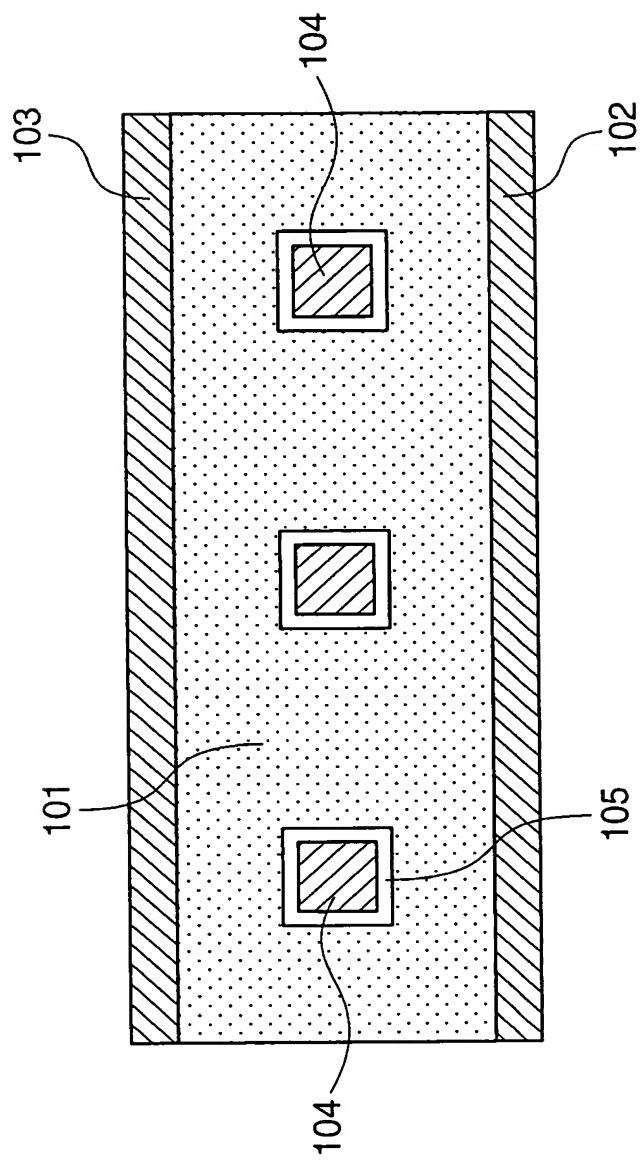
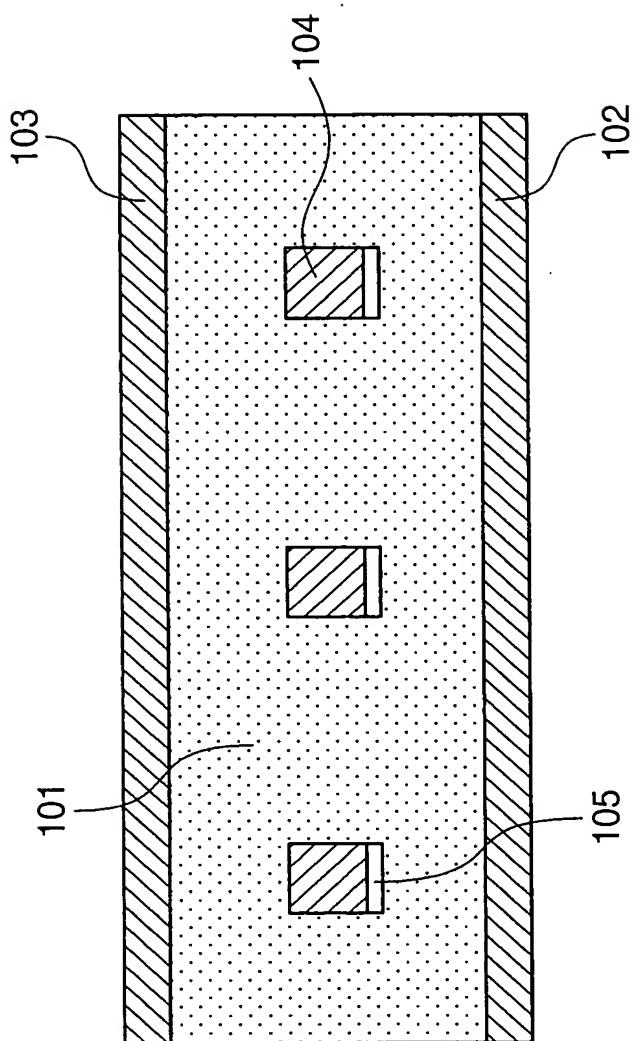


FIG. 5



**FIG. 6**

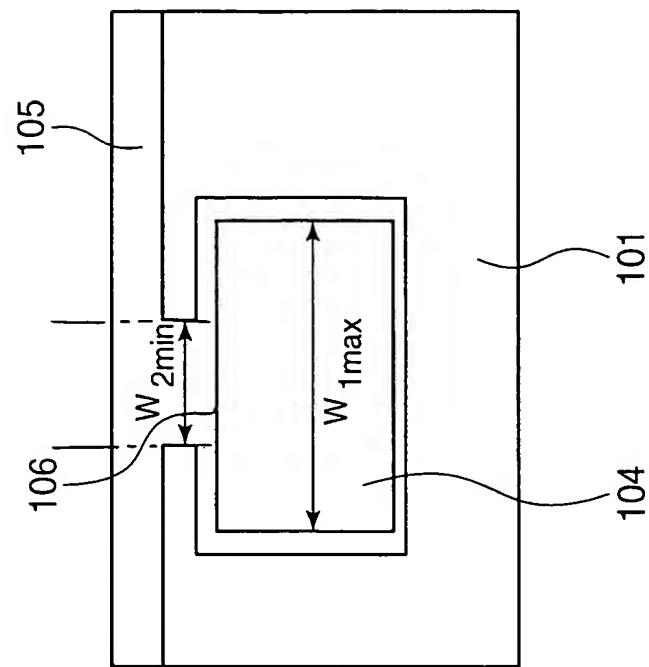


FIG. 7B

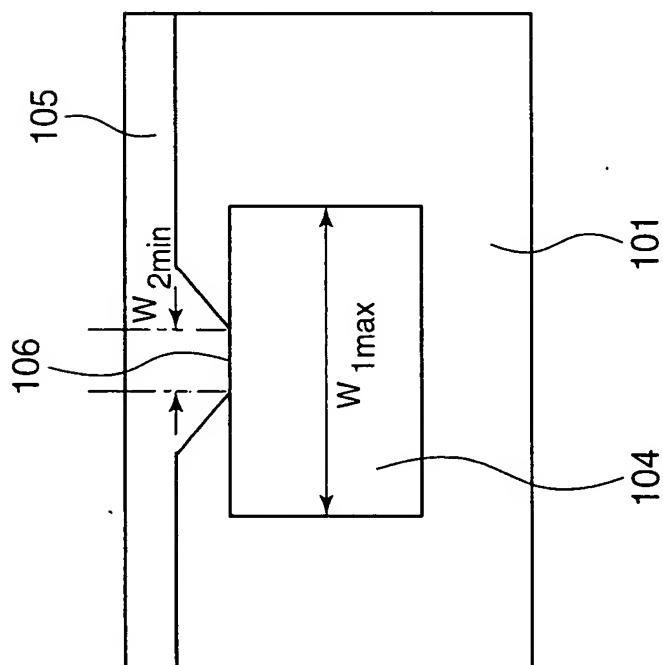


FIG. 7A

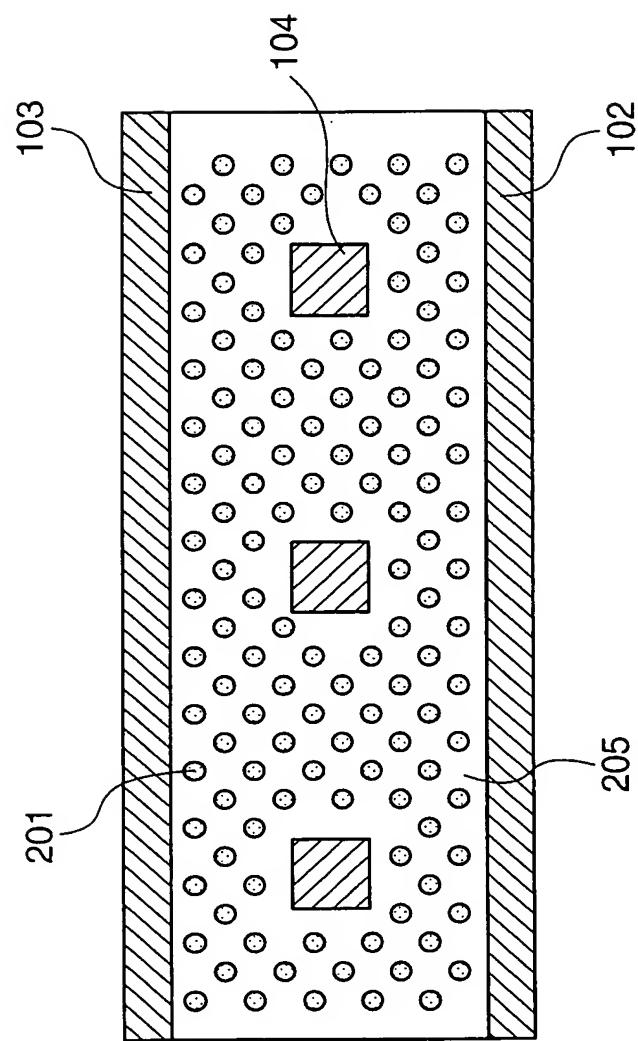


FIG. 8

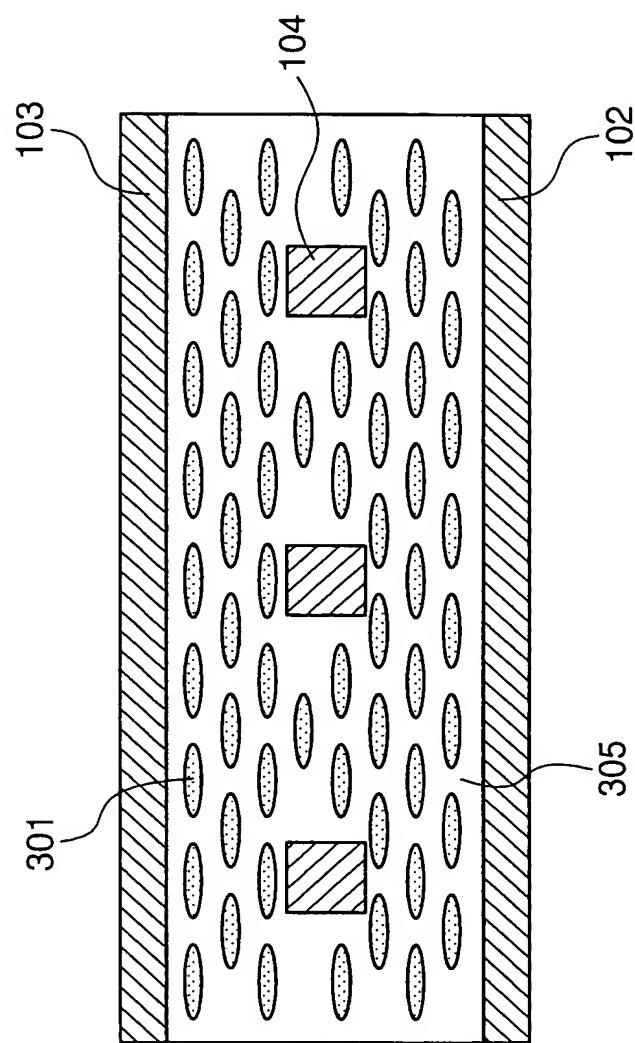


FIG. 9

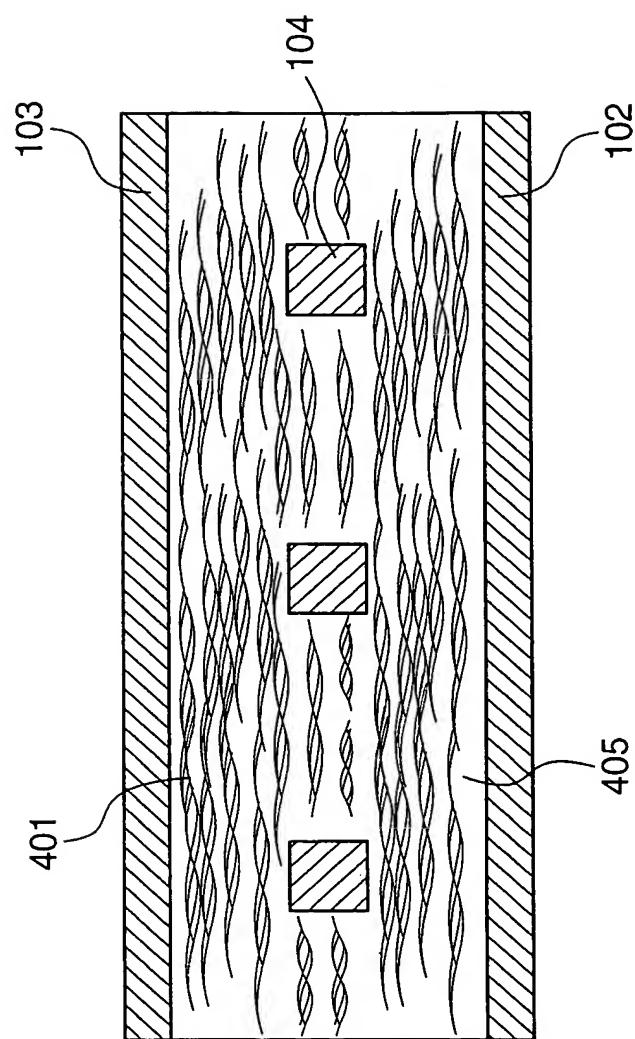


FIG. 10

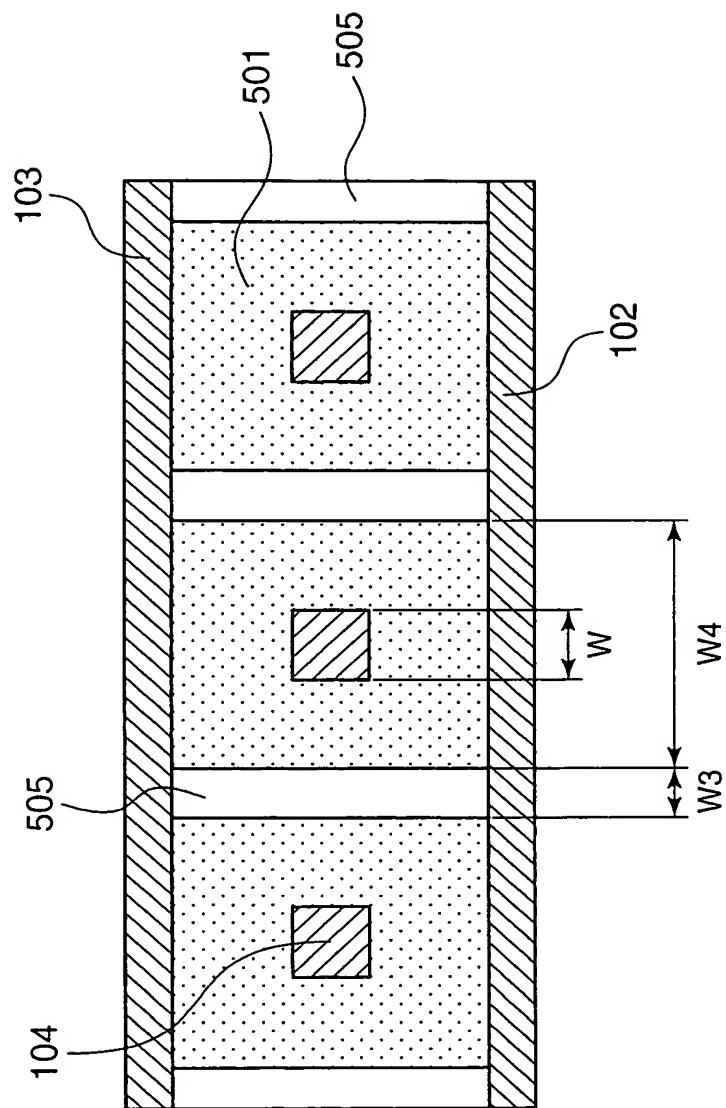


FIG. 11

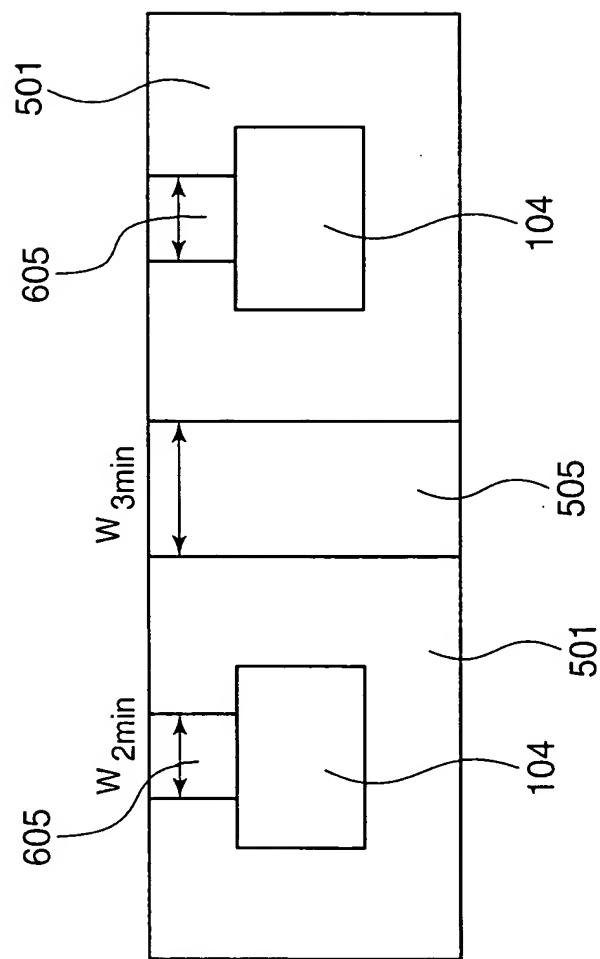
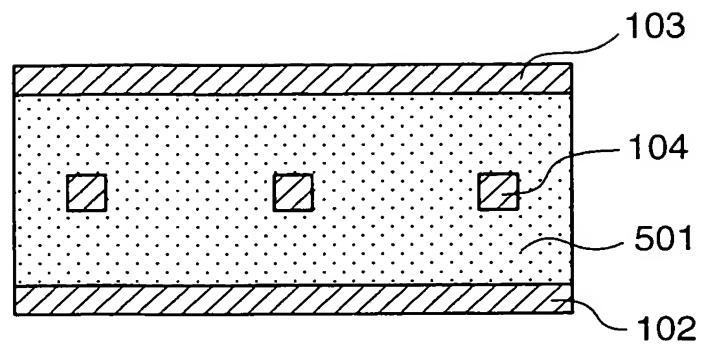
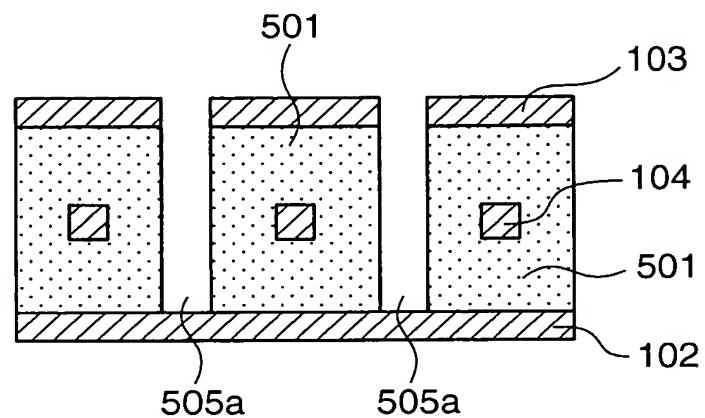
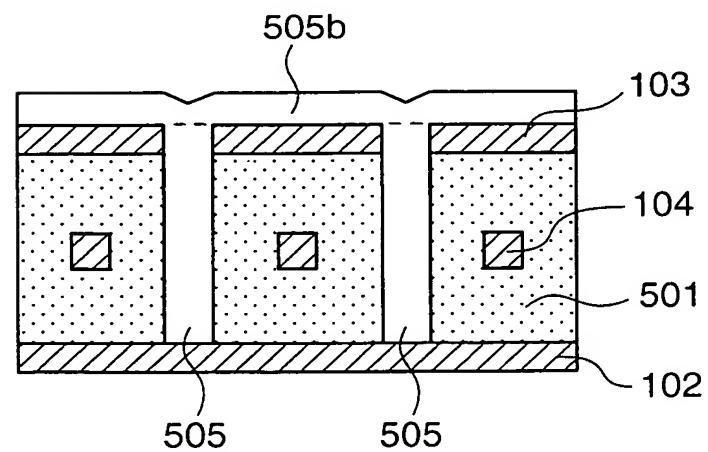


FIG. 12

**FIG. 13A****FIG. 13B****FIG. 13C**

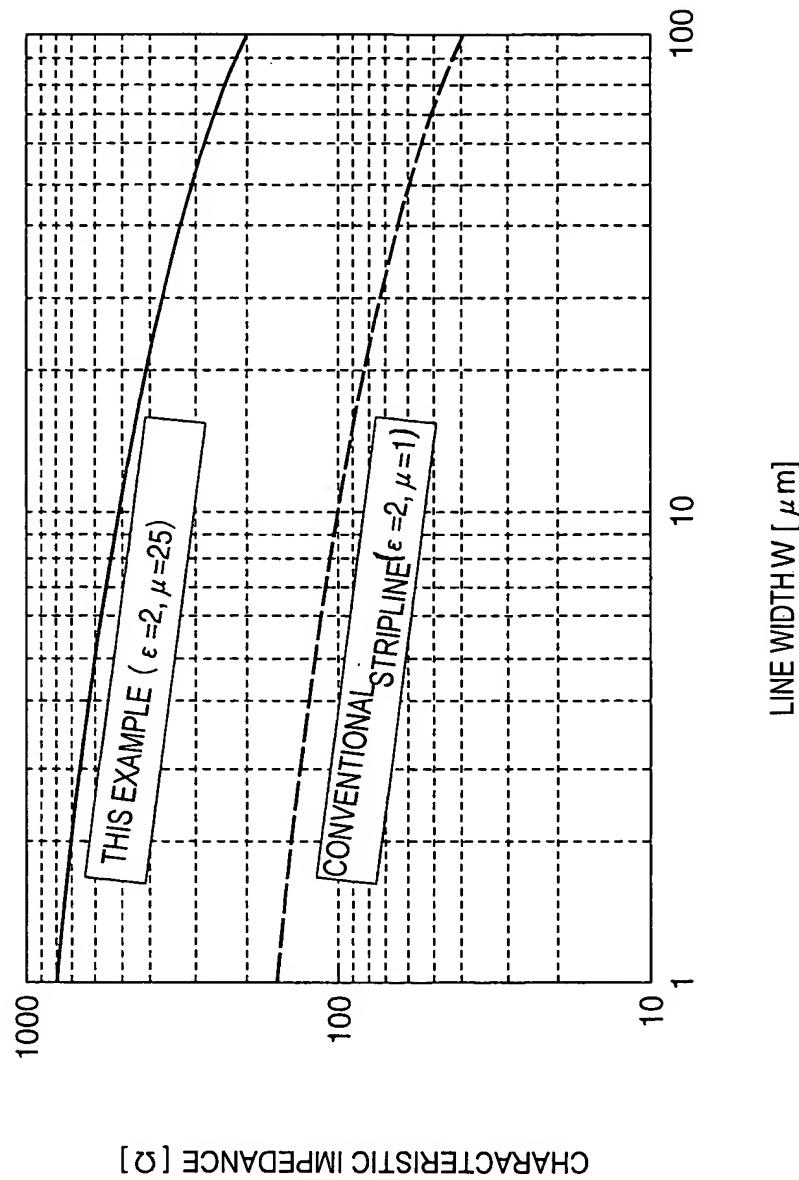
CHARACTERISTIC IMPEDANCE ( $\Omega$ )

FIG. 14

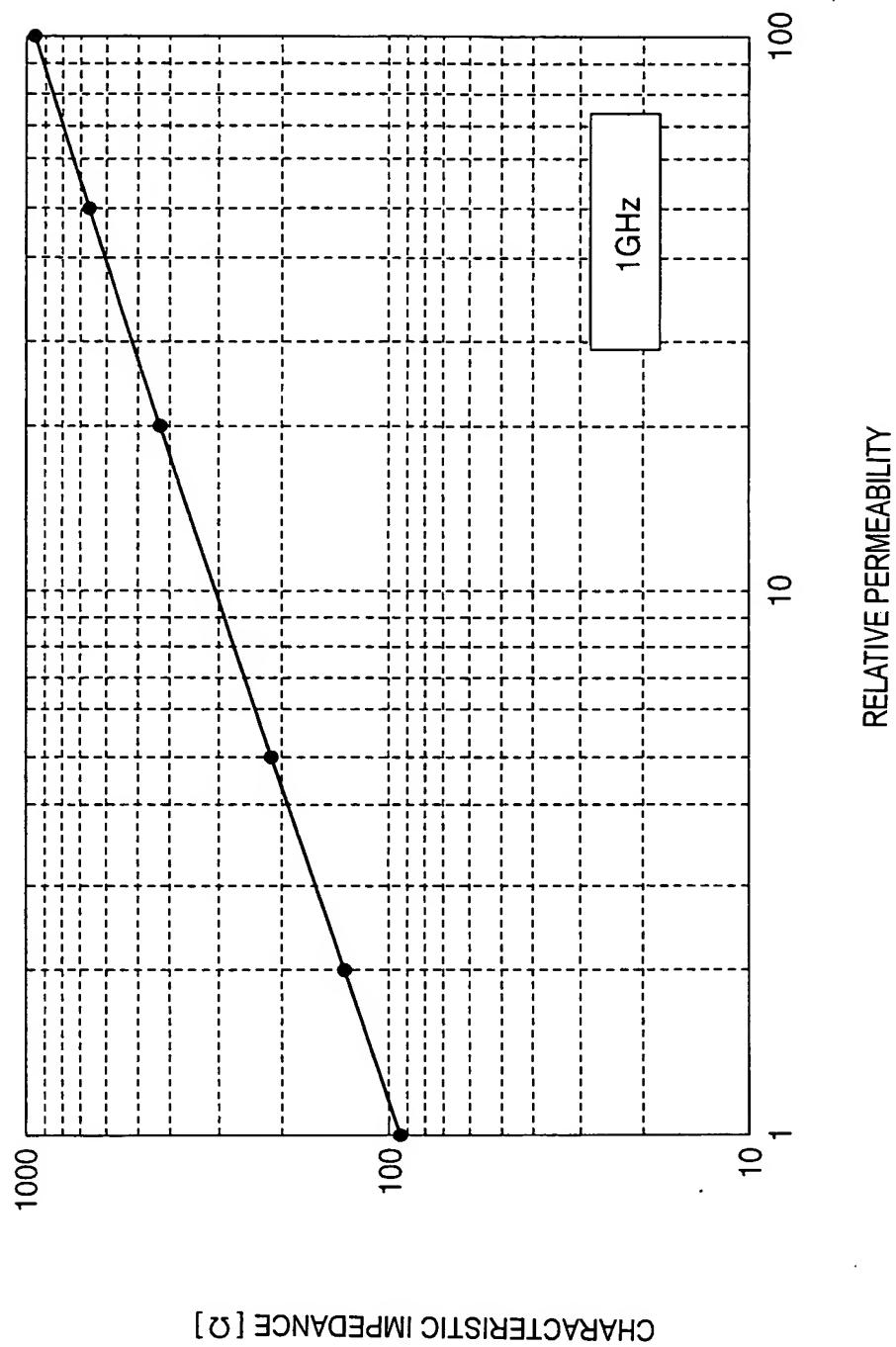


FIG. 15

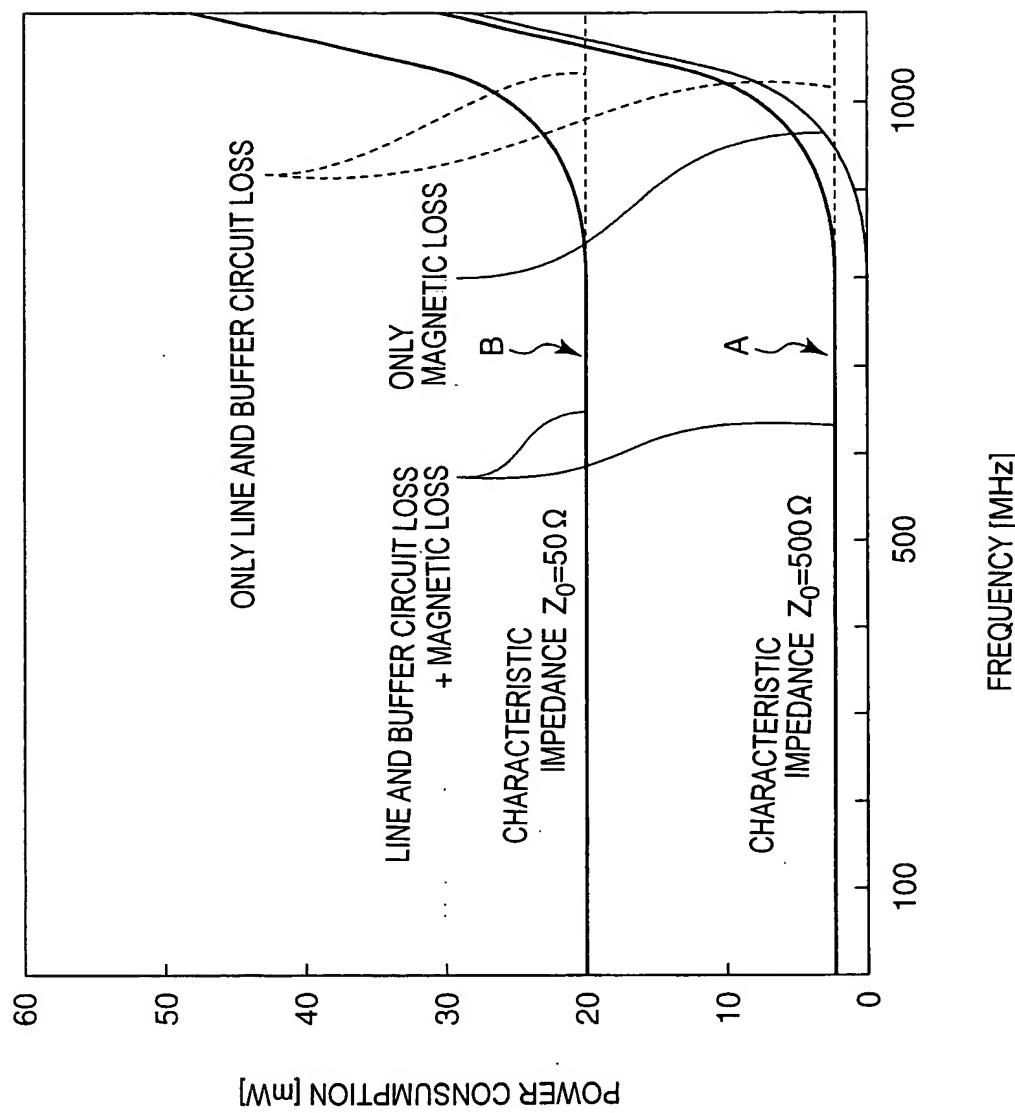
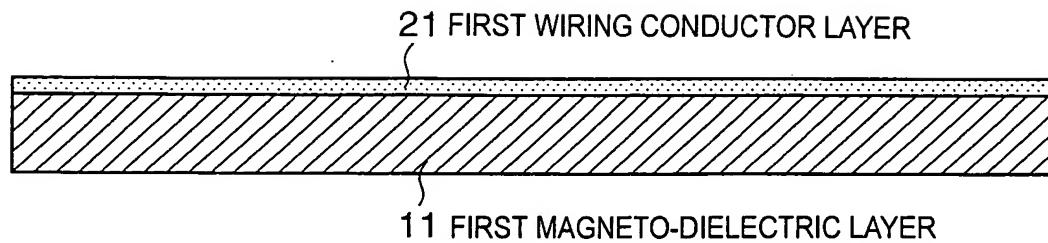
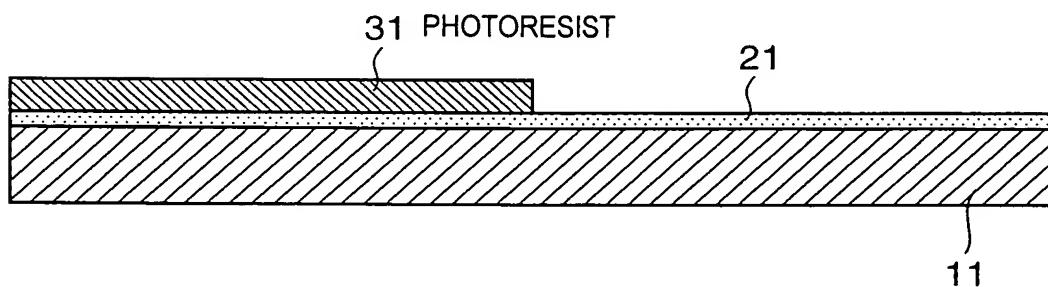


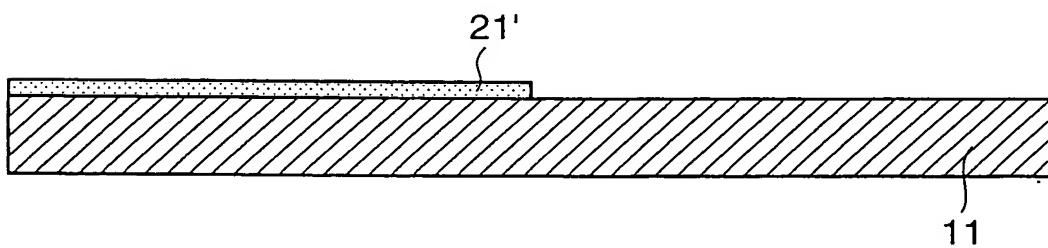
FIG. 16



**FIG. 17**



**FIG. 18**



**FIG. 19**

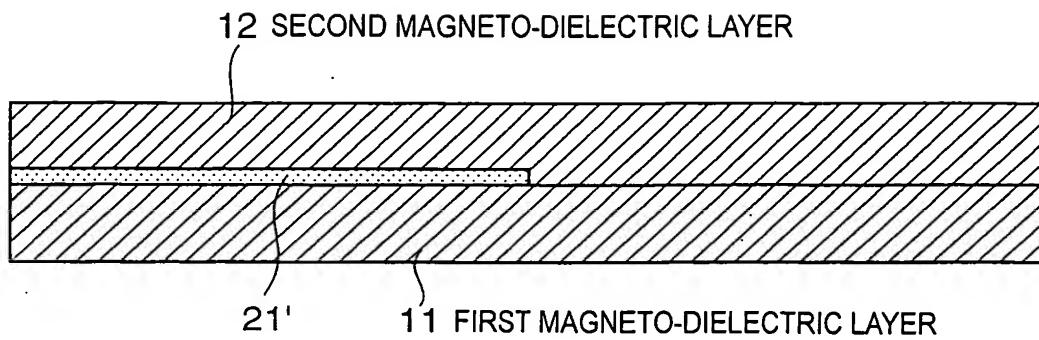


FIG. 20

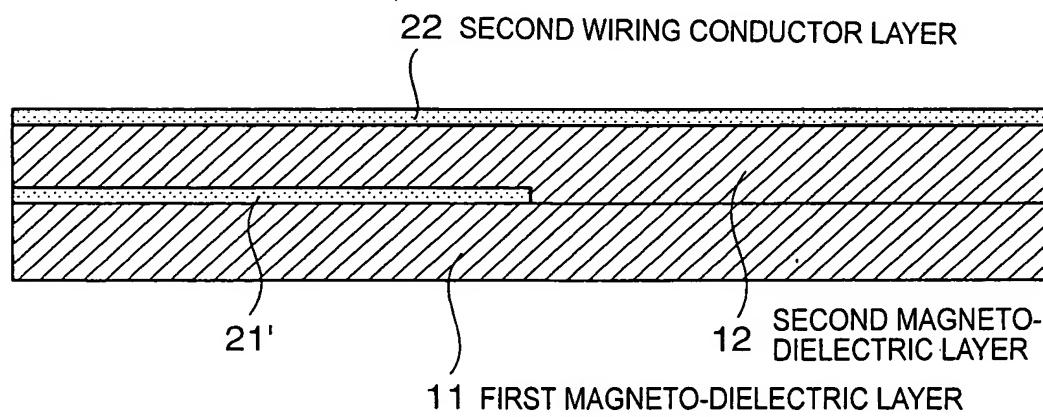


FIG. 21

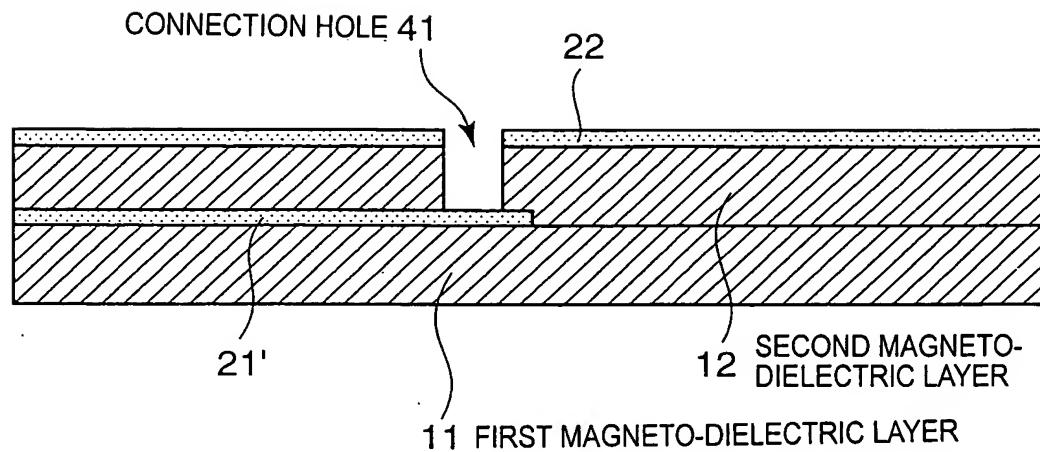


FIG. 22

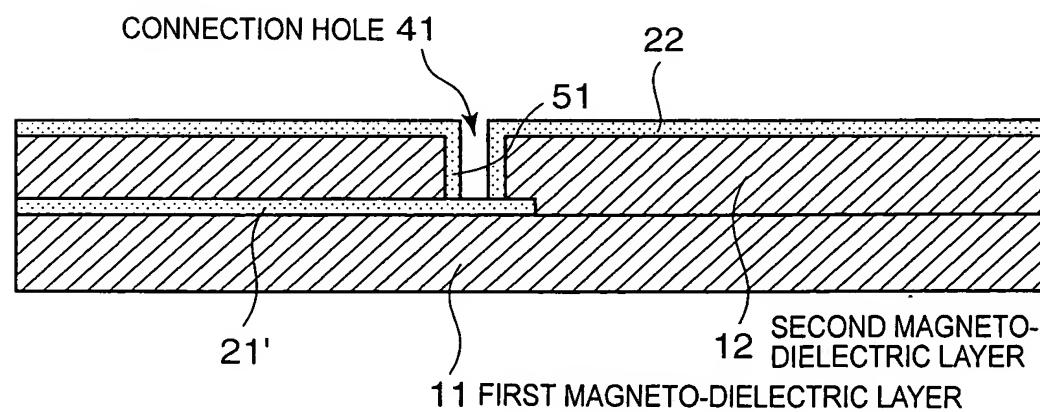


FIG. 23

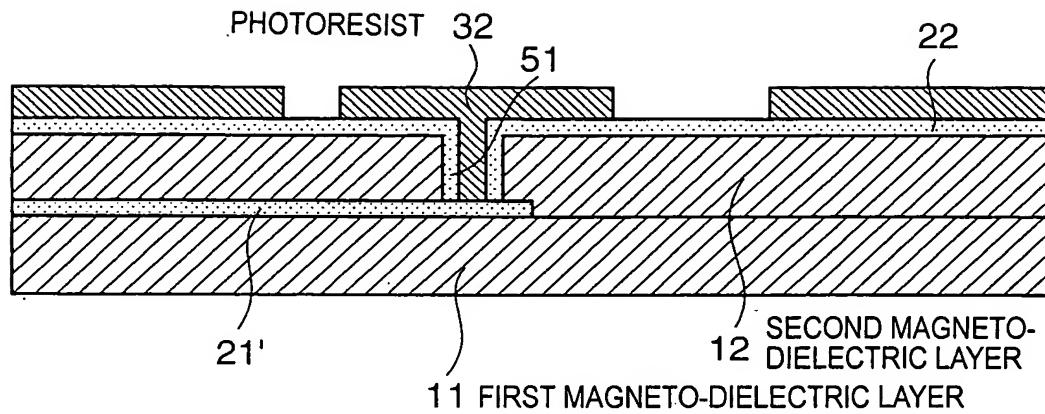


FIG. 24

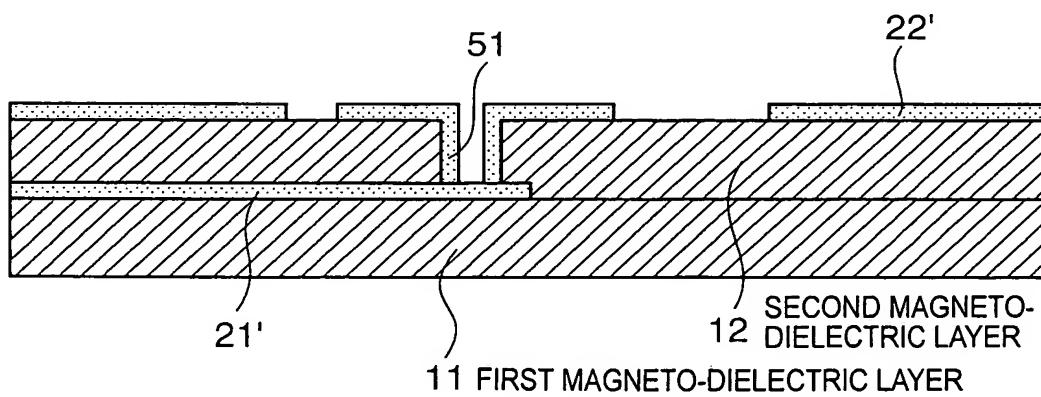


FIG. 25

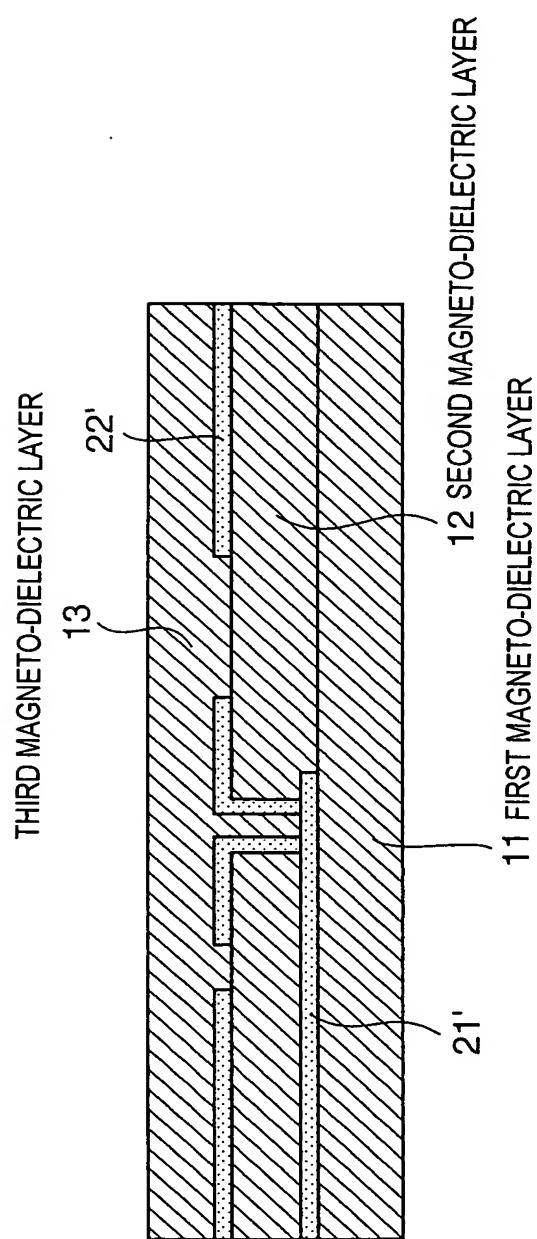


FIG. 26

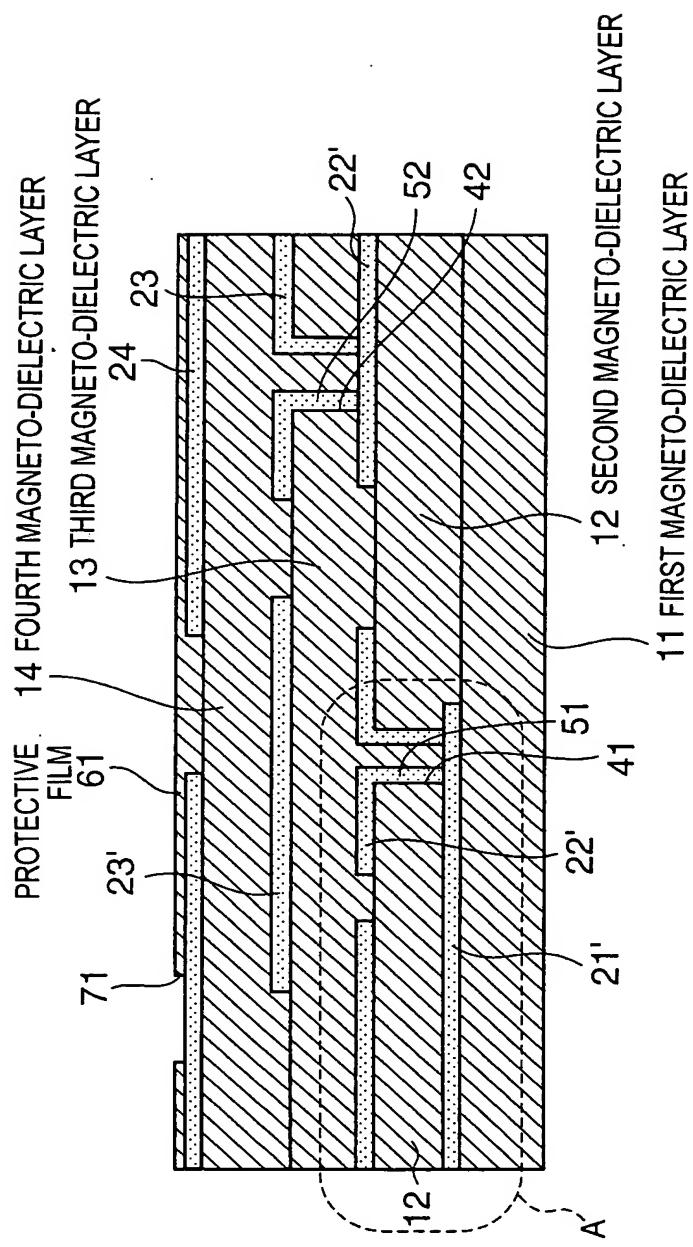


FIG. 27

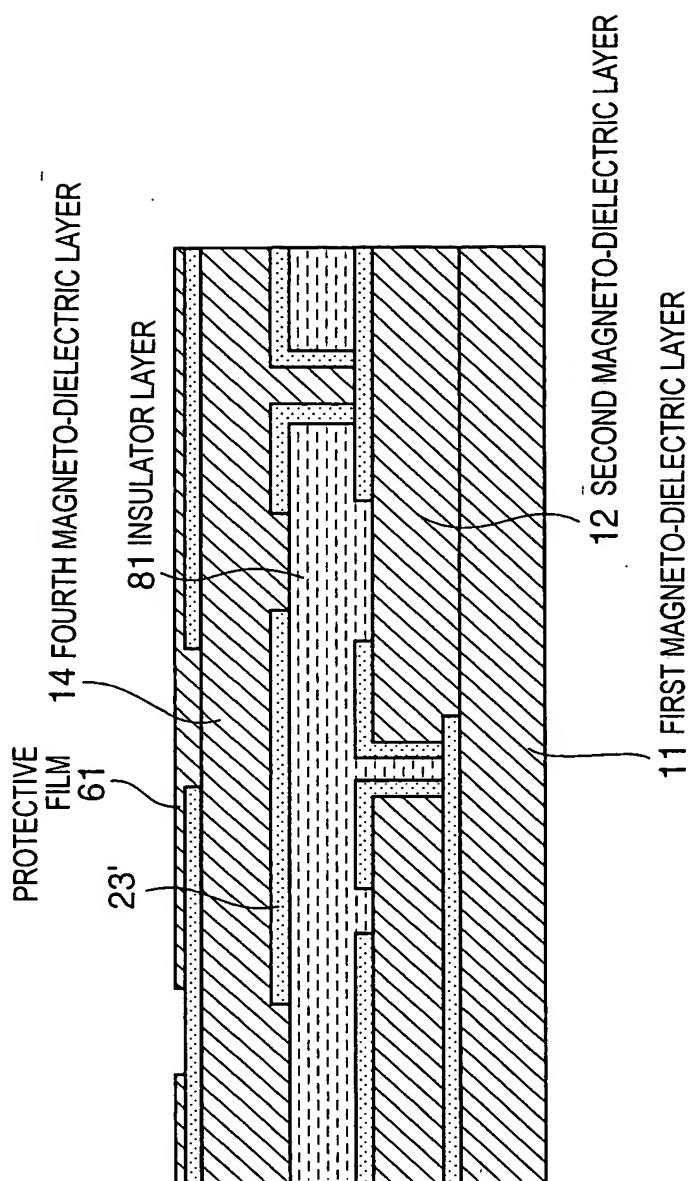


FIG. 28

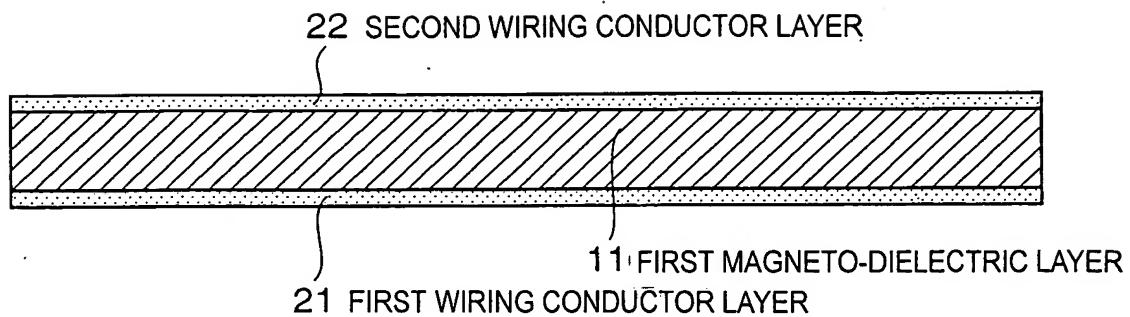


FIG. 29

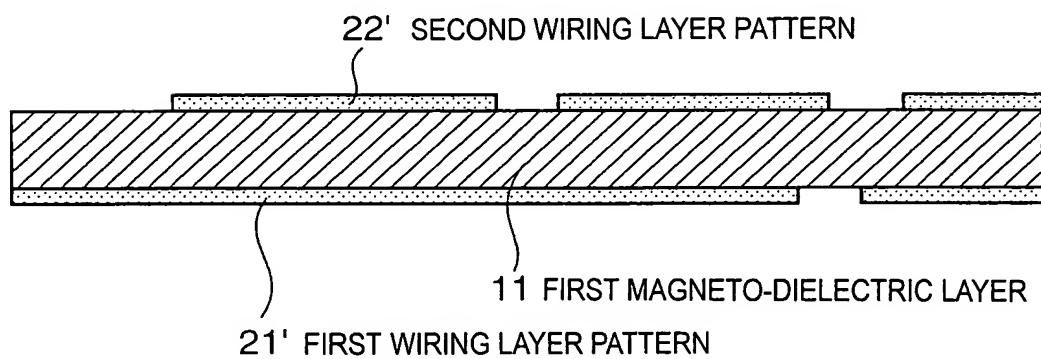


FIG. 30

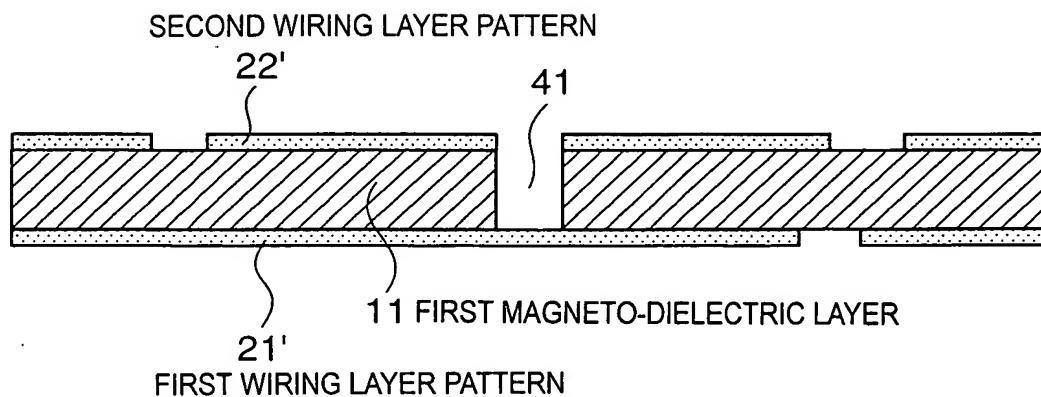


FIG. 31

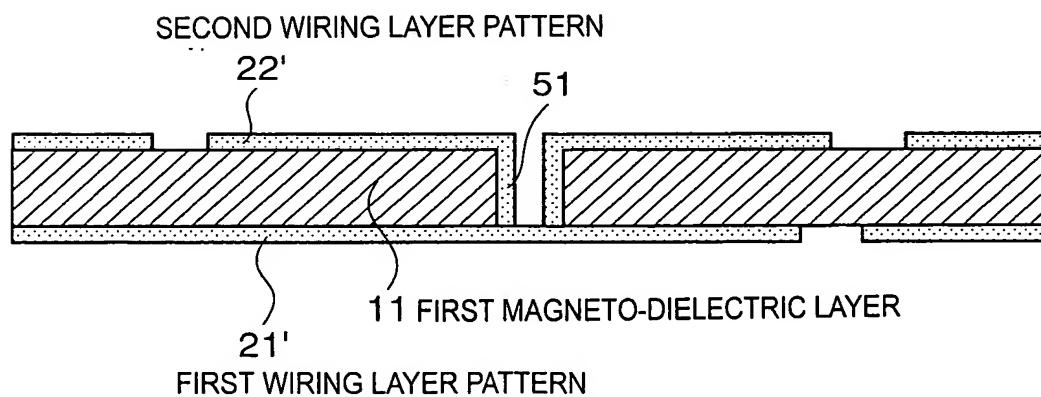


FIG. 32

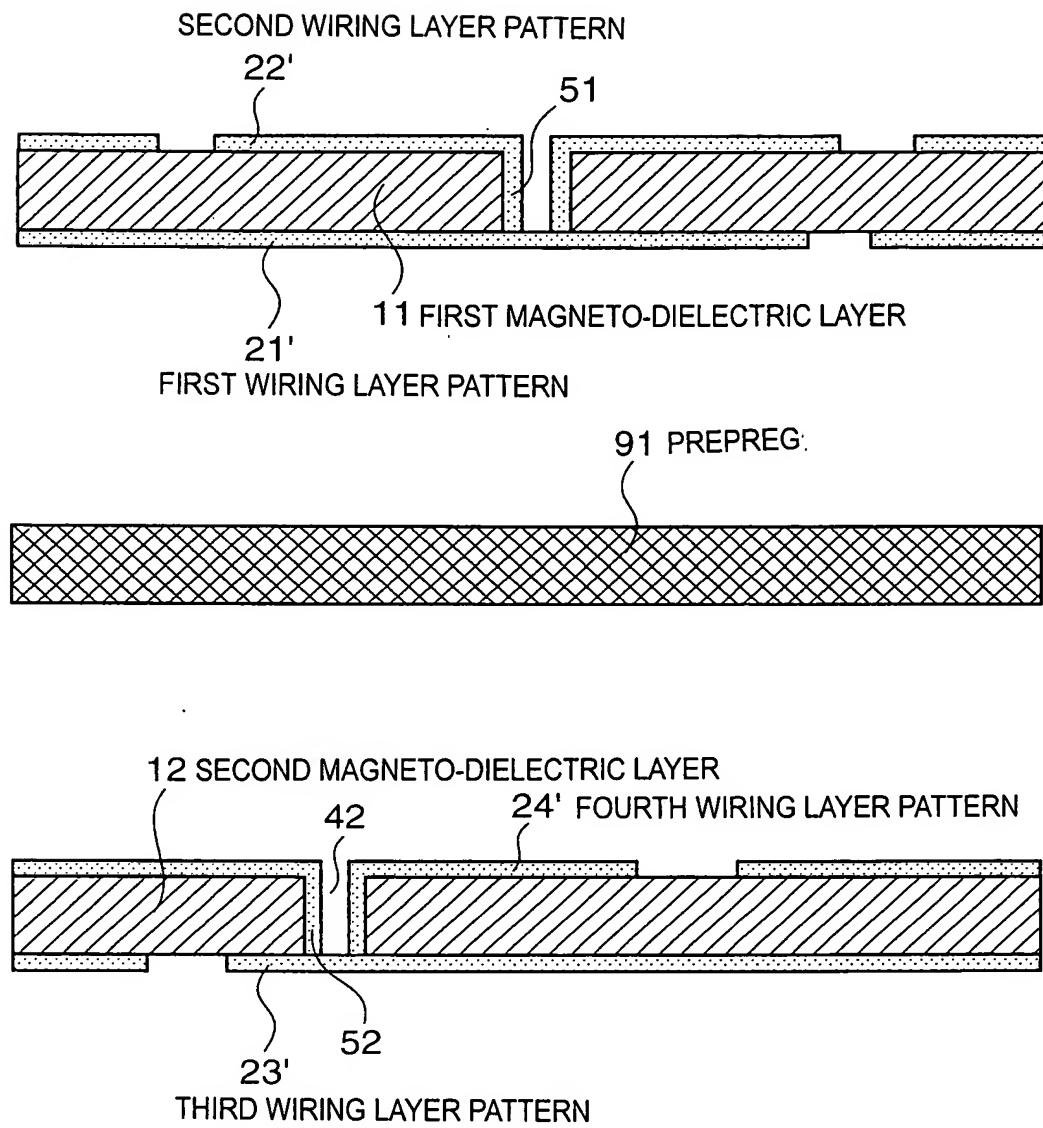


FIG. 33

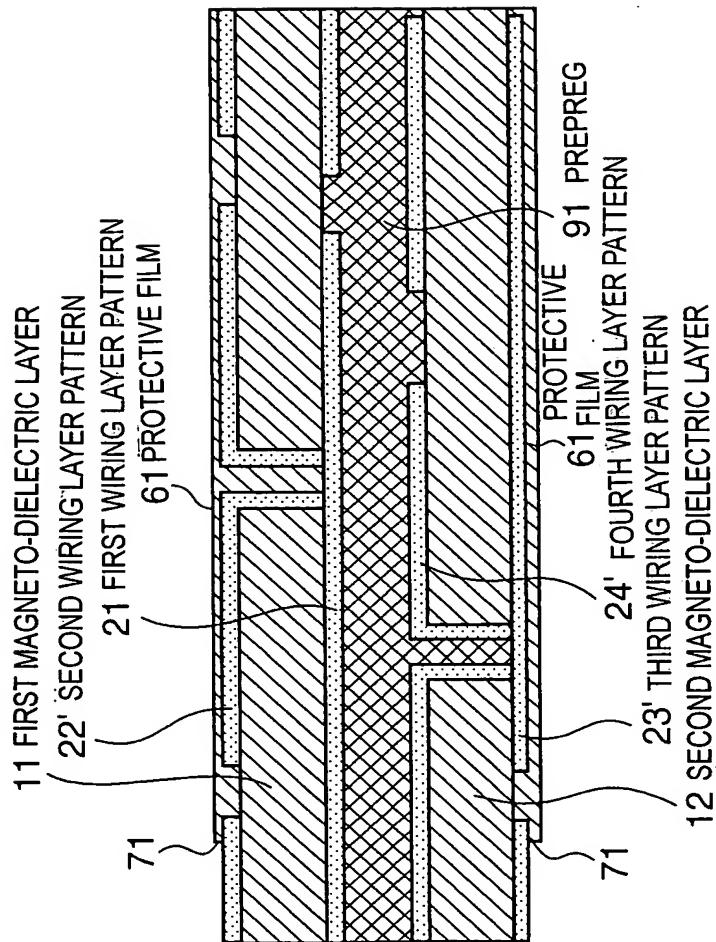


FIG. 34

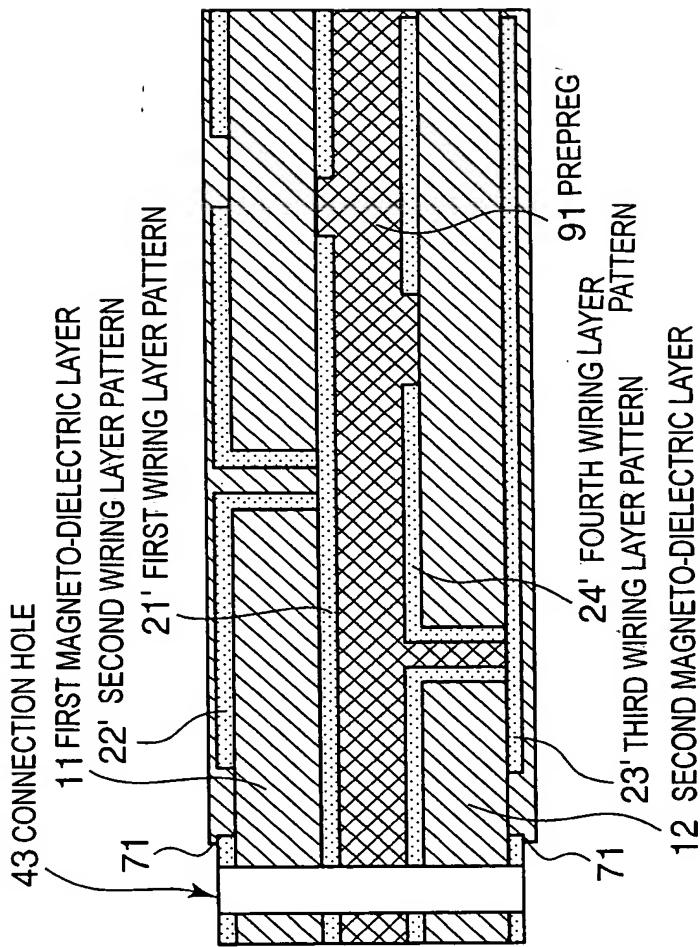


FIG. 35

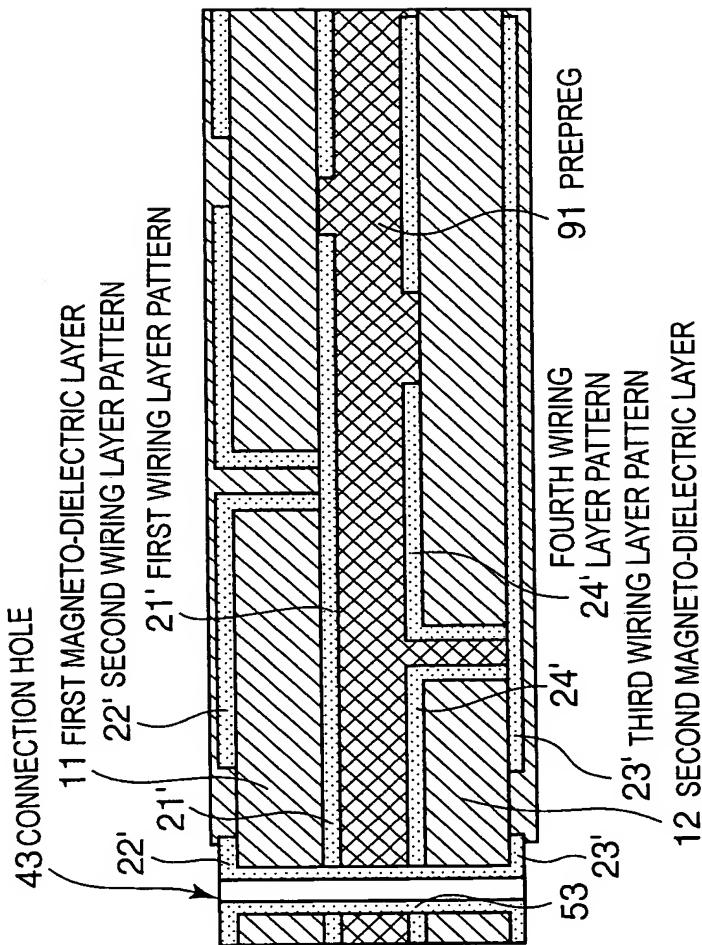


FIG. 36



GENERAL LASER PROCESSING  
(CARBON DIOXIDE LASER OR THE LIKE)

FIG. 37A

FIG. 37B

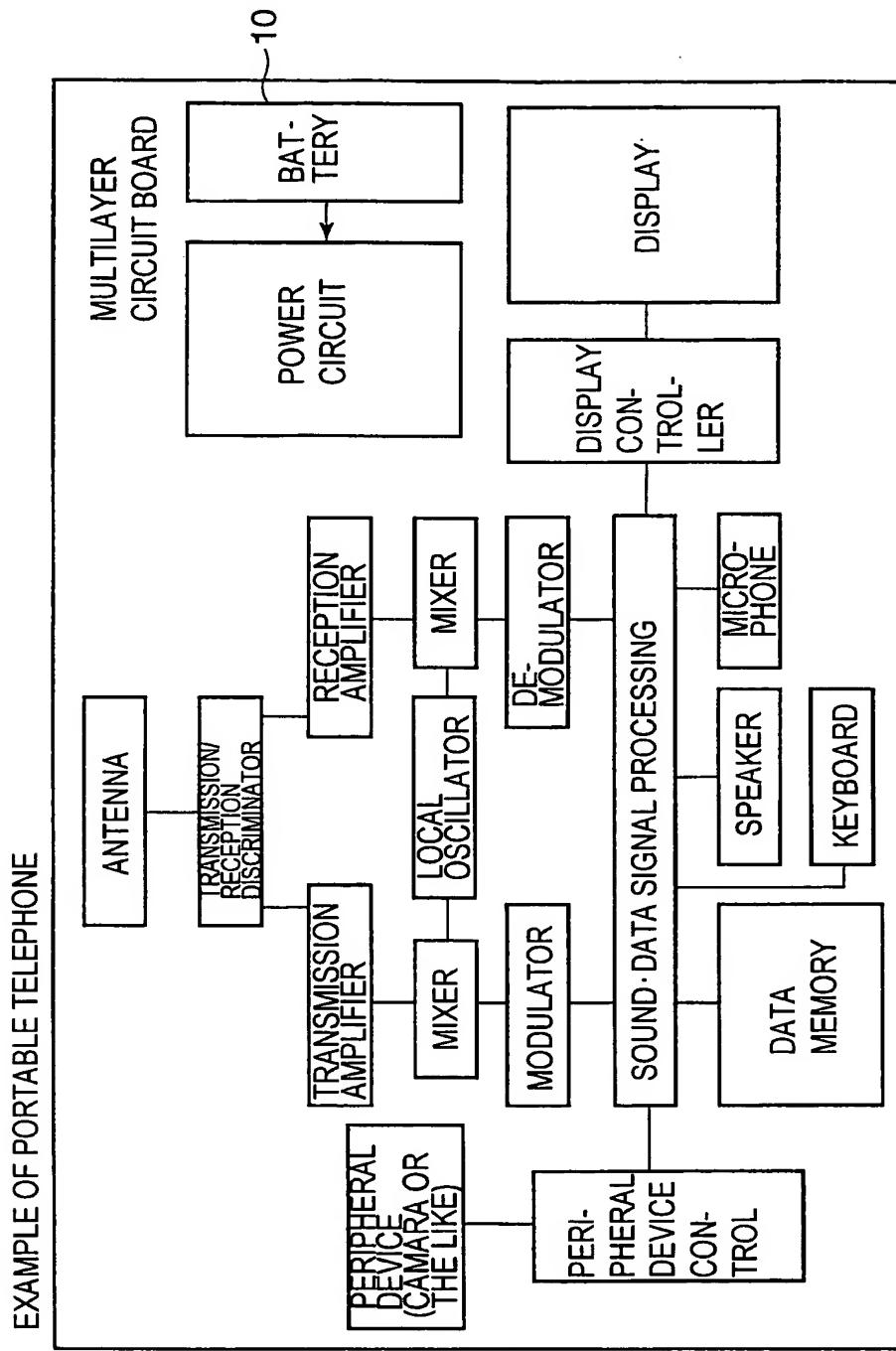
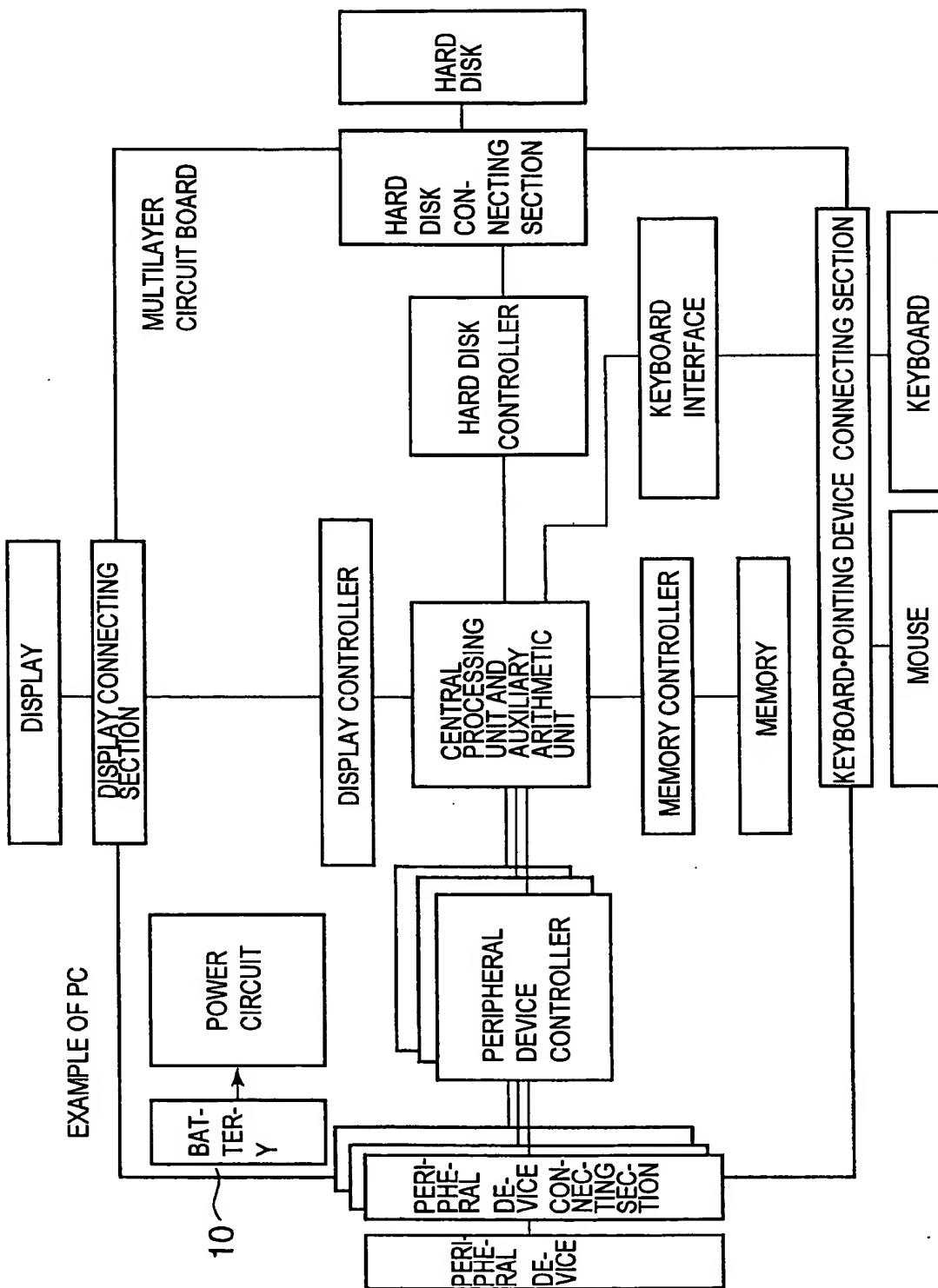


FIG. 38



**FIG. 39**

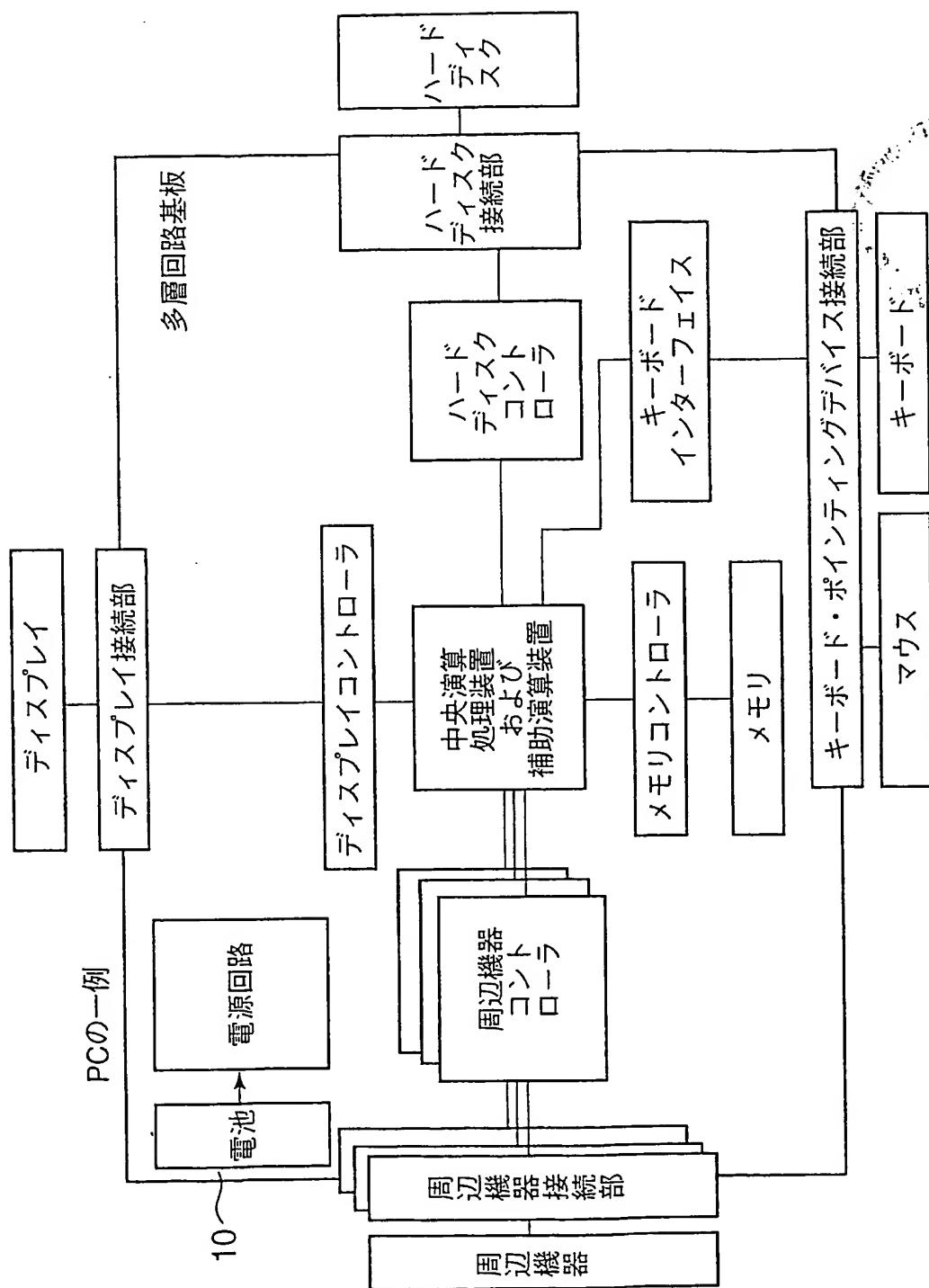


図 39